

TRANSMITTAL

Electronic Version v1.1

Stylesheet Version v1.1.0

Title of Invention	Method of Improved High K Dielectric-Polysilicon Interface for CMOS Devices		
Application Number :	09/941827		
Date :	2001-08-29		
First Named Applicant:	Weimer Ronald A.		
Confirmation Number:	7551		
Attorney Docket Number:	MTI-31532		
<p>I hereby certify that the use of this system is for OFFICIAL correspondence between patent applicants or their representatives and the USPTO. Fraudulent or other use besides the filing of official correspondence by authorized parties is strictly prohibited, and subject to a fine and/or imprisonment under applicable law.</p> <p>I, the undersigned, certify that I have viewed a display of document(s) being electronically submitted to the United States Patent and Trademark Office, using either the USPTO provided style sheet or software, and that this is the document(s) I intend for initiation or further prosecution of a patent application noted in the submission. This document(s) will become part of the official electronic record at the USPTO.</p>			
Submitted By:	Elec. Sign.	Sign. Capacity	
Kristine M. Strodthoff Registered Number: 34259	/kms/	Attorney	

Documents being submitted:	Files
us-fee-sheet	MTI-31532-usfees.xml us-fee-sheet.xsl us-fee-sheet.dtd
us-ids	MTI-31532-usidst.xml us-ids.dtd us-ids.xsl
Comments	